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Phase-change metasurface slows down light

Din-Ping Tsai ¹✉

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All-dielectric metasurface analogue of electromagnetically induced transparency (EIT) is highly desirable for developing compact and low-loss nanophotonic devices, such as dispersion-tunable slow-light meta devices. However, it remains challenging to realize dynamic control of EIT in all-dielectric metasurfaces in the near-infrared region. To this end, researchers at the Dalian University of Technology in China have demonstrated active tuning of EIT-featuring Mie resonances in an all-dielectric metasurface based on patterned germanium antimony telluride (GST), a phase-changing material whose optical response differs significantly between the amorphous and crystalline phases.

Experimentally, they have achieved a spectral tuning range of 360 nm and a relative modulation contrast of 80% at the EIT resonance wavelength by laser-induced phase switching of GST. Surprisingly, the extreme dispersion associated with the EIT resonance results in the group velocity of a near-infrared light beam 335 times slower than that in a vacuum. We anticipate that this optically tunable metasurface device can find its applications in a broad field, and the generic design approach can be extended to more comprehensive optical frequencies by using novel phase-changing materials.

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